

8012 RECEIPT  
**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Shunichi SEKI et al.

Application No.: 09/423,969

Filed: November 17, 1999

For: THIN FILM PATTERNING SUBSTRATE AND SURFACE TREATMENT  
THEREFOR



ATTN: Application Branch

Docket No.: 104741

**NOTIFICATION OF ERRORS IN FILING RECEIPT**

Assistant Commissioner for Patents  
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Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. No corrected filing receipt is requested in view of the fact that the errors will not be transferred to the Letters Patent upon its issuance under the Patent and Trademark Office policy announced at 1220 O.G.42 (March 9, 1999). Please contact the undersigned if there is any question about the accuracy of these corrections.

Respectfully submitted,

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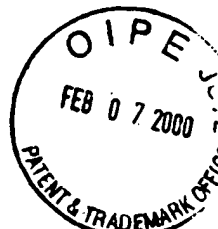
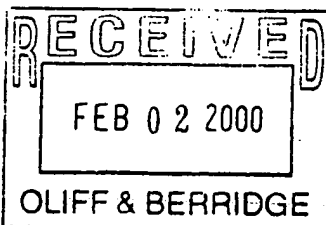
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTORNEY DOCKET NO.	DRWGS	TOT CL	IND CL
09/423,969	11/17/99	1762	\$2,466.00	104741	24	80	10

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Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts of Application" ("Missing Parts Notice") in this application, please submit any corrections to this Filing Receipt with your reply to the "Missing Parts Notice." When the PTO processes the reply to the "Missing Parts Notice," the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

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CONTINUING DATA AS CLAIMED BY APPLICANT-  
THIS APPLN IS A 371 OF PCT/JP99/01327 03/17/99

FOREIGN APPLICATIONS-	JAPAN	10-67508	03/17/98
	JAPAN	11-32123	02/10/98

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TITLE

~~SUBSTRATE FOR PATTERNING THIN FILM AND SURFACE TREATMENT THEREOF~~  
~~THIN FILM PATTERNING SUBSTRATE AND SURFACE TREATMENT THEREOF~~  
PRELIMINARY CLASS: 427

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DATA ENTRY BY: ORDONEZ, MARTA

TEAM: 11 DATE: 01/31/00

(See reverse for new important information)